Applicants:

YOON, Joo-Sun; KIM, Bong-Ju; TAE, Seung-Gyu;

KIM, Hyun-Young

Assignee:

SAMSUNG ELECRONICS CO., LTD.

Title:

METHOD FOR MANUFACTURING THIN FILM TRANSISTOR

ARRAY PANEL FOR DISPLAY DEVICE

Int'l. Appl. No.:

PCT/KR02/01773

Int'l. Filing Date:

18 September 2002

Examiner:

Unknown

Group Art Unit:

Unknown

Docket No.:

AB-1379 US

San Jose, California September 27, 2004

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INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR § 1.97(b)

Dear Sir:

Pursuant to 37 C.F.R. § § 1.56, 1.97 and 1.98, Applicants wish to call the documents listed on the enclosed Form PTO-1449 (1 page) to the Examiner's attention for the above-identified patent application. Copies of the listed documents are enclosed with the exception of the U.S. patents. The relevance of any non-English documents is explained in the accompanying English abstracts and the enclosed International Search Report for International Application No. PCT/KR02/01773, which is the international stage of the present application.

Citation of the above documents shall not be construed as:

- 1. an admission that the documents are necessarily prior art with respect to the instant invention;
- 2. a representation that a search has been made, other than as described above; or
- an admission that the information cited herein is, or is considered to be, material to patentability as defined in § 1.56(b).

MacPherson Kwok Chen & Heid LLP 1762 Technology Drive Suite 226 San Jose, CA 95110 Telephone: (408) 392-9250 Facsimile: (408) 392-9262 No fee is believed to be required. If a fee is required for this Information Disclosure Statement, please charge the fee to Deposit Account No. 50-2257. This paper is being submitted in duplicate.

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Respectfully submitted,

David W. Heid

Attorney for Applicant

Reg. No. 25,875

Sheet 1 of 1

U.S. Department of Commerce, Patent and Trademark Office					Atty. Docket No.		1 Stid 15.094 B	
					AB-1379 US		Unknown	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT					Applicant(s)			
(Use several sheets if necessary)					YOON, Joo-Sun et al.			
					Filing Date		Group	
					Herewith		Unknown	
			U.S.	Patent Documents			<u> </u>	
*Examiner Initial		Document Number	Date	Name	Class Subclass		Filing Date If Appropriate	
v .	AA	US 5,548,424	08/20/1996	Takao et al.				
	AB	US 5,706,064	01/06/1998	Fukunaga et al.				
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	AM	JP 05-203988	08/13/1993	Japan				X
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	AQ	Patent Abstracts	of Japan, Publica	tion No. 01-100518, (04/18/1989, 1 pag	ge		
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